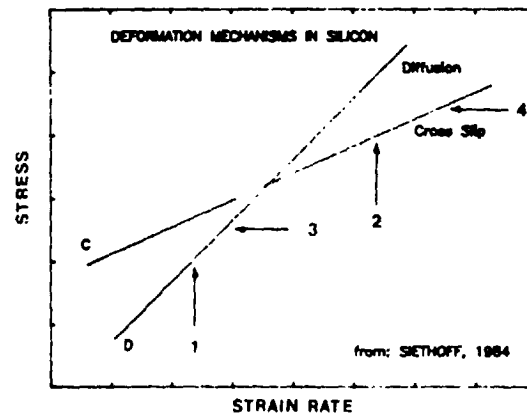
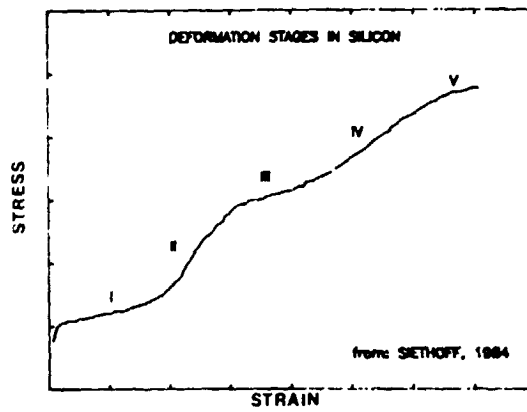
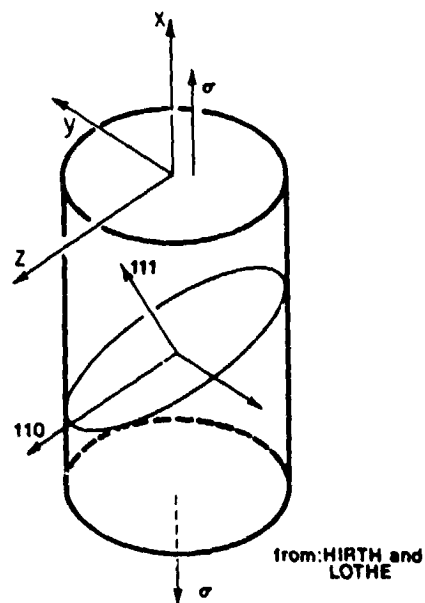




### Deformation in Silicon



### Resolving Applied Stress on a Dislocation

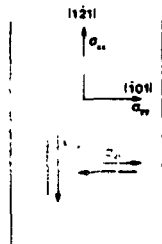


Calculation of Slip Systems

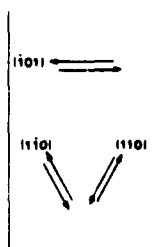
STRESS	ACTING ON		SCHMIDT FACTOR	
	PLANE	DIRECTION		
$\sigma_{xx}$ $\tau_{zy}$	$\bar{1}\bar{1}\bar{1}$	$10\bar{1}$	0	
		$0\bar{1}1$	0.2722	
		$110$	0.2722	
	$1\bar{1}\bar{1}$	$110$	-0.1361	
		$0\bar{1}1$	0.4082	
		$101$	0.2722	
	$\bar{1}\bar{1}1$	$\bar{1}10$	0.4082	
		$011$	-0.1361	
		$101$	0.2722	
	$111$	$\bar{1}01$	0	
		$1\bar{1}0$	0	
		$0\bar{1}1$	0	
	$\sigma_{yy}$ $\tau_{xy}$	$\bar{1}\bar{1}\bar{1}$	$0\bar{1}1$	-0.4082
		$\bar{1}\bar{1}1$	$1\bar{1}0$	-0.4082
	$\sigma_{xy}$ or $\sigma_{yx}$	$\bar{1}\bar{1}\bar{1}$	$10\bar{1}$	0.9428

Resultant Stresses

APPLIED STRESS



SHEAR STRESS

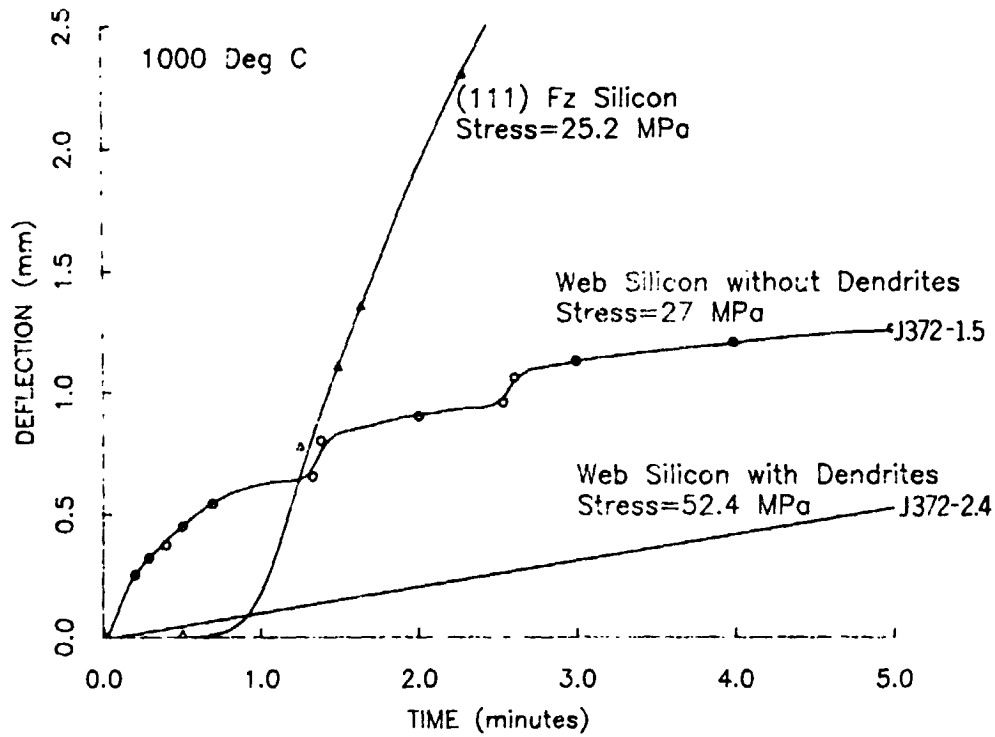


RESULTING FROM

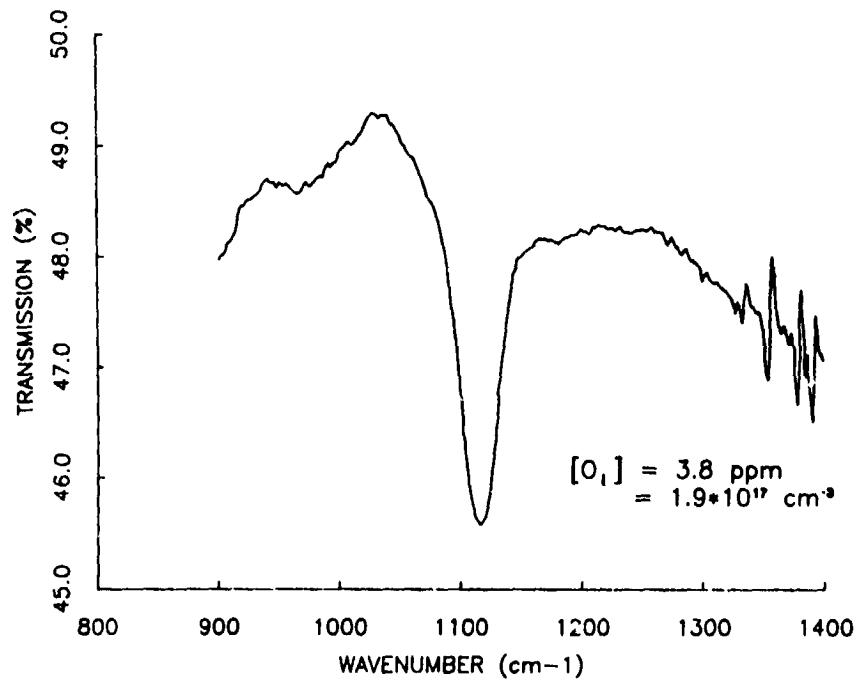
$\sigma_{yy}$  or  $\sigma_{xx}$

$\sigma_{xx}$  or  $\sigma_{yy}$

Deflection Versus Time for Four-Point Bending

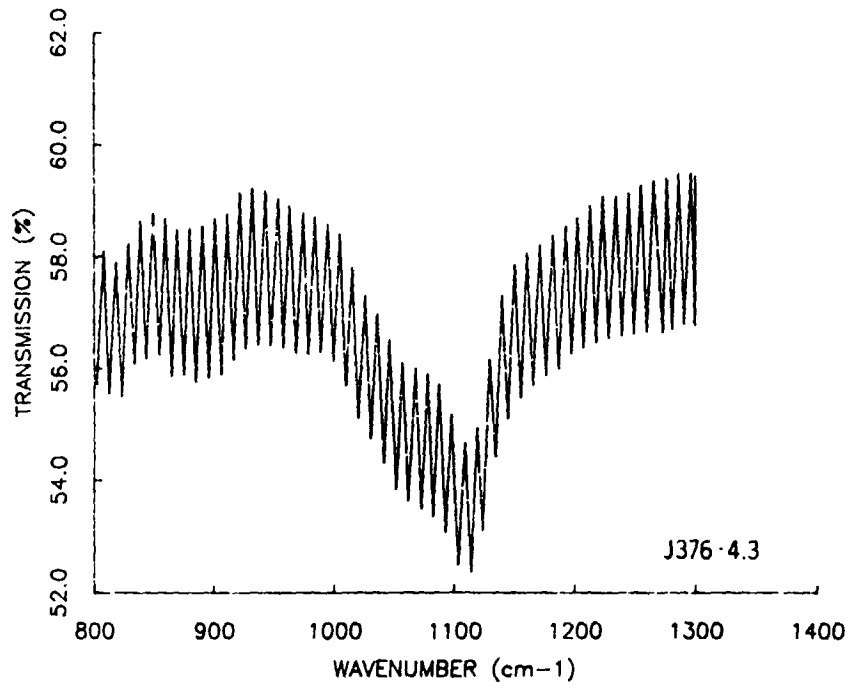


IR Transmission Versus Wavenumber for Czochralski Silicon

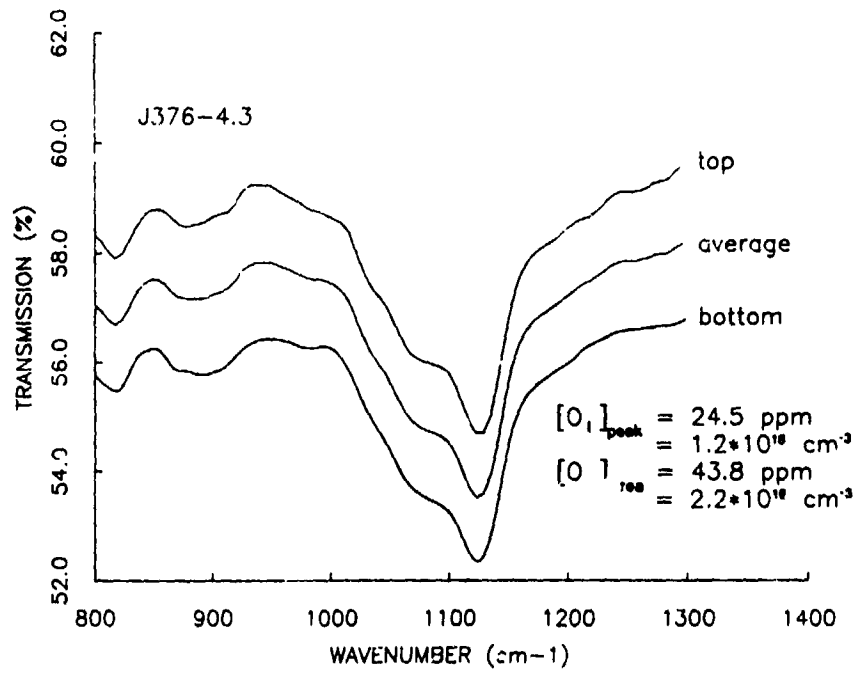


# ADVANCED SILICON SHEET

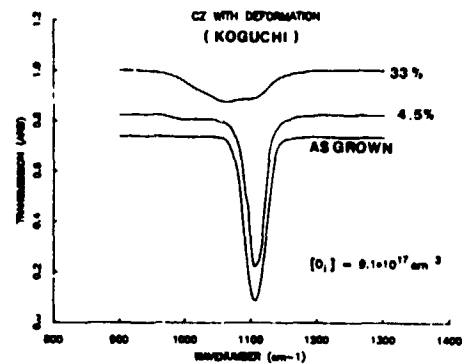
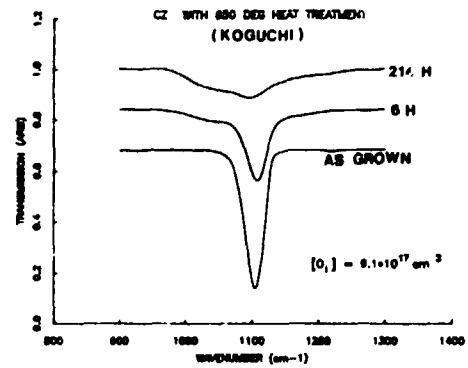
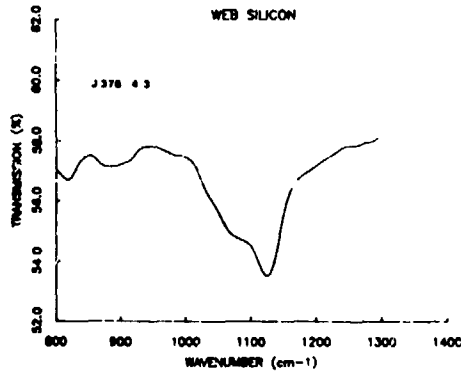
## IR Transmission Versus Wavenumber for Web Silicon



## IR Transmission Versus Wavenumber for Web Silicon



IR Transmission Versus Wavenumber



Conclusions

Creep behavior of Web is very different from any seen for single crystal silicon.

Perhaps modeled between single crystal and polycrystalline

Perhaps related to stress in the ribbon.

Oxygen level in Web silicon is near the saturation level at the melting point of silicon.

Interstitial oxygen is only about 1/2 the total oxygen content.

The rest of the oxygen is in a state close to that of interstitial oxygen that is affected by its environment.